



2621  
#4

501.40830X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): HIROI, et al

Serial No.: 09/986,299

Filed: November 8, 2001

For: PATTERN INSPECTION METHOD AND APPARATUS

Group: 2621

**RECEIVED**

Examiner:

MAY 6 8 2002

**PROPOSED AMENDMENT TO THE DRAWINGS** Technology Center 2600  
**AND CORRECTED SUBSTITUTE DRAWINGS**

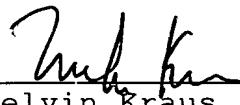
Commissioner for Patents  
Washington, D.C. 20231

May 3, 2002

Sir:

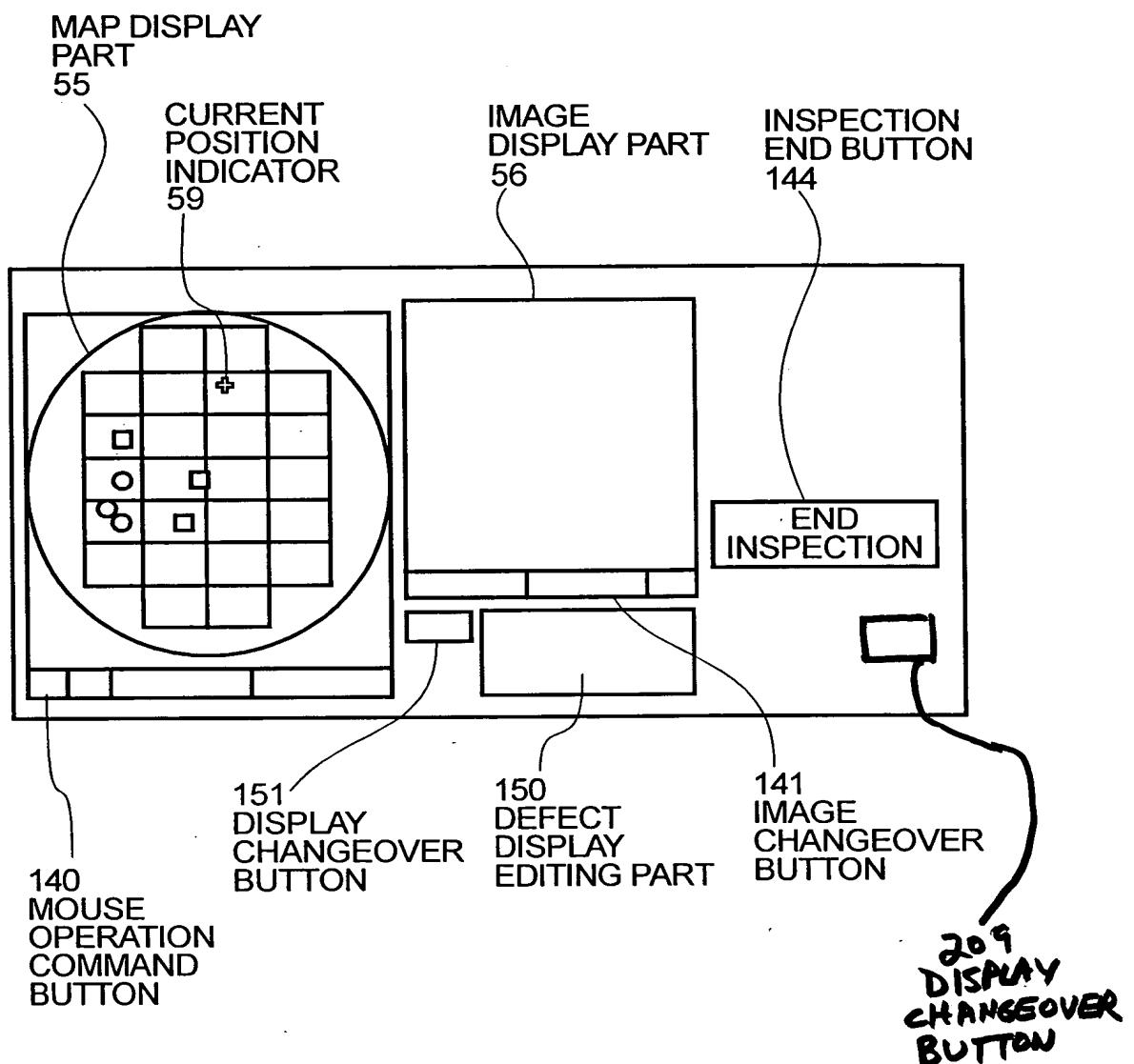
It is proposed that the drawings in the above-identified application be amended in accordance with the attached redlined print and corrected drawings incorporating the changes are submitted herewith.

Respectfully submitted,

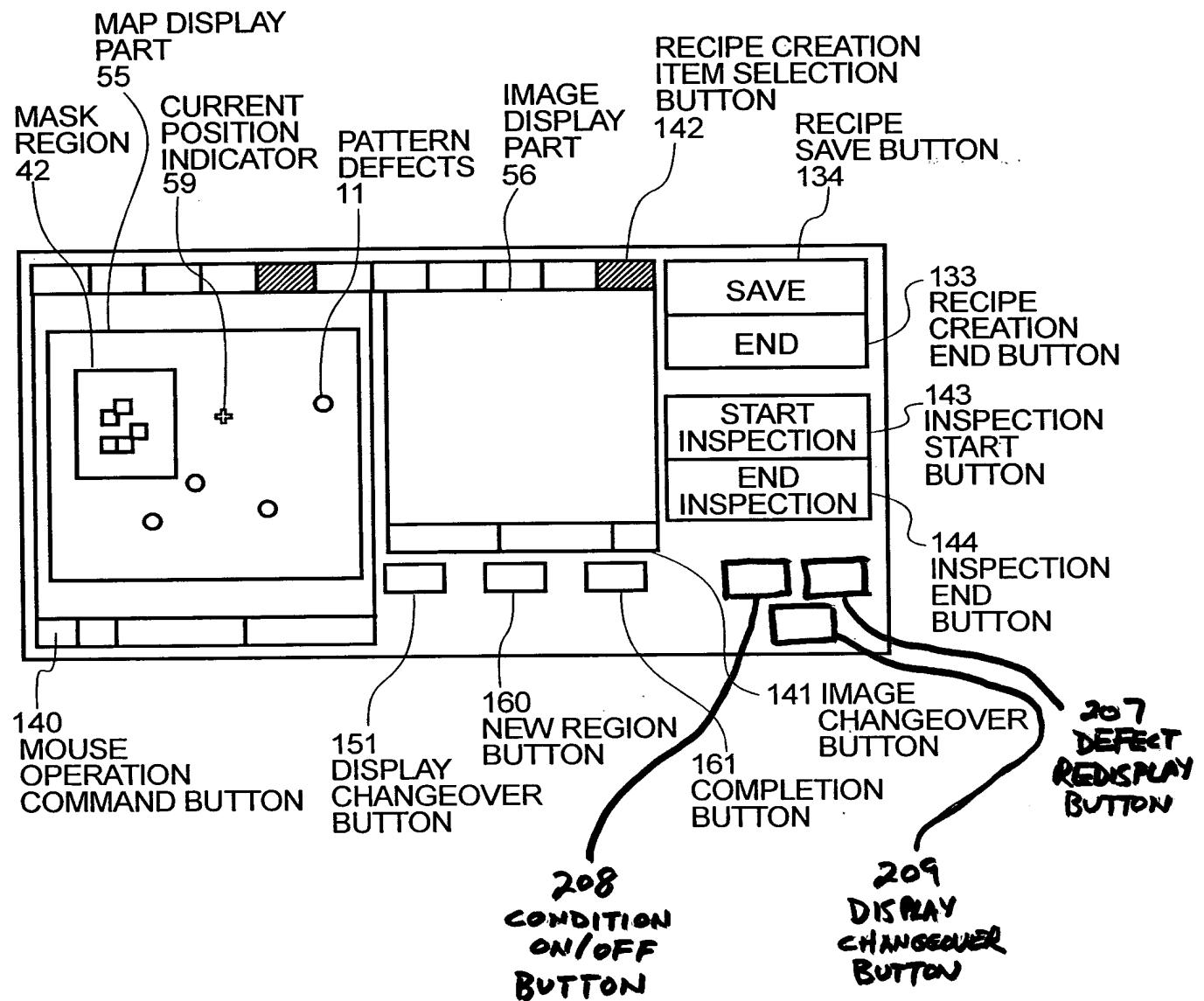
  
\_\_\_\_\_  
Melvin Kraus  
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ANTONELLI, TERRY, STOUT & KRAUS, LLP

MK/cee  
Attachment(s)  
(703) 312-6600

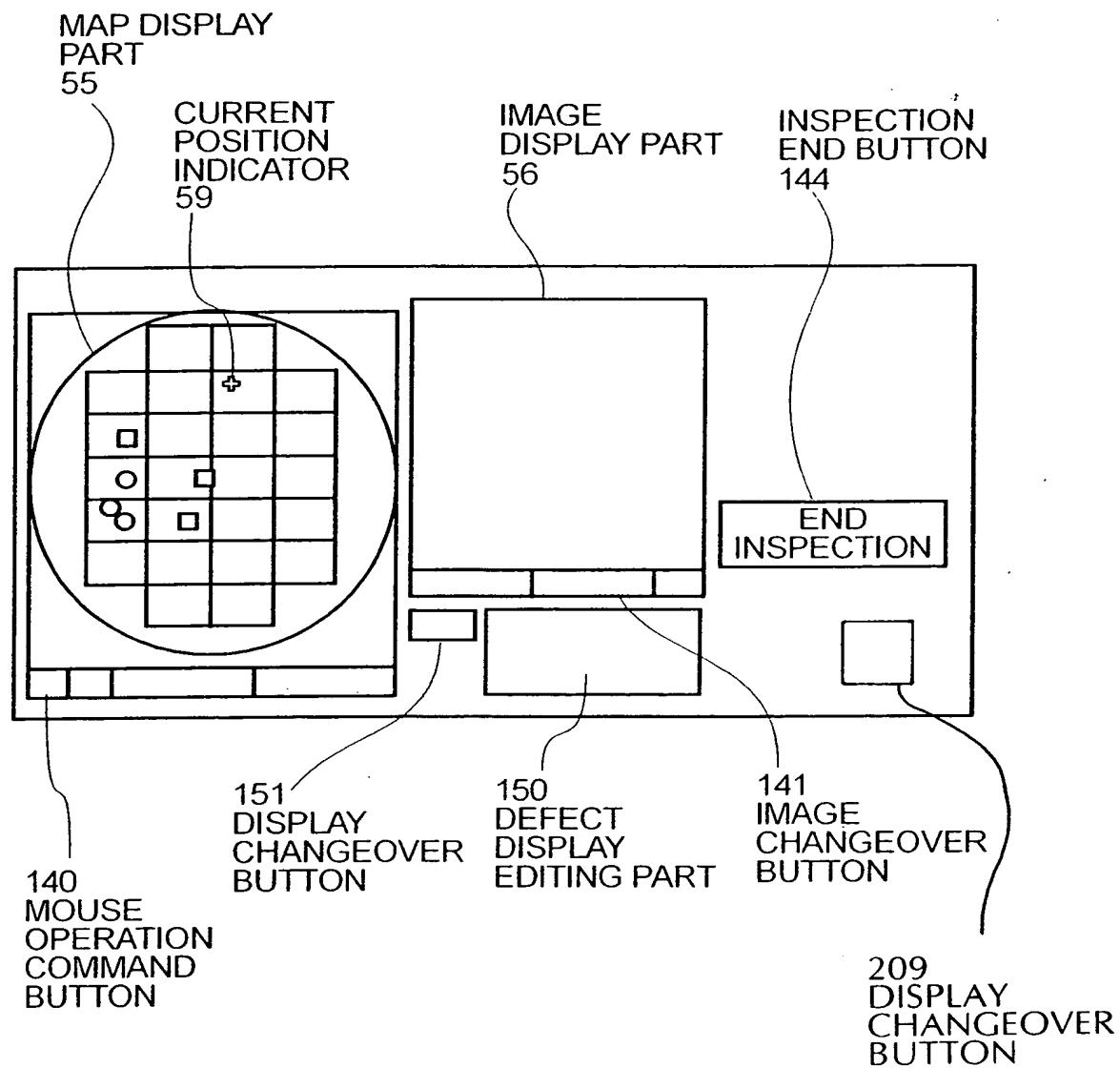
# FIG.15



# FIG.17



# FIG.15



**FIG.17**

